



#2823

500:34397CV2
Response Under 37 CFR 1.116
Expedited Procedure
Group No. 2823

O.K To
ENTER AS
OFFICE
T.D
6/27/03

DO NOT
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T.D
5/14/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MIURA, et al
Serial No.: 09/977,207
Filed: October 16, 2001
For: SEMICONDUCTOR DEVICE AND PRODUCTION
THEREOF
Group: 2823
Examiner: T. Dang

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7/00 (24)
FJONES
12-17-02

Julio
6/24/03

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

December 10, 2002

Sir:

In response to the Office Action of September 10, 2002, please amend the
above-identified application as follows:

IN THE CLAIMS

Please amend Claims 18 and 23 as follows:

C1
18. (amended) A process for producing a semiconductor device, which comprises
the steps of: